



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#18  
Taylor  
11/13/02

Application Serial No. .... 09/905,286  
Filing Date .... July 13, 2001  
Inventor .... Cem Basceri et al.  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 1762  
Examiner .... Fuller, Eric B.  
Attorney's Docket No. .... MI22-1724  
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate  
Comprising Dielectric Layers

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
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601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated:

November 7, 2002

By:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

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